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**Notice of Allowability**

Application No.

10/030,723

Examiner

Ram N. Kackar

Applicant(s)

TYLER, JAMES SCOTT

Art Unit

1763

**-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--**

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1. ☒ This communication is responsive to amendment of 5/9/2005.
2. ☒ The allowed claim(s) is/are 1-7,9,10,12,49,50 and 52-56.
3. ☒ The drawings filed on 11 July 2003 are accepted by the Examiner.
4. ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
  - a) ☐ All b) ☐ Some\* c) ☐ None of the:
    1. ☐ Certified copies of the priority documents have been received.
    2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
    3. ☐ Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

\* Certified copies not received: \_\_\_\_\_.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.

**THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.**

5. ☐ A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
  6. ☐ CORRECTED DRAWINGS (as "replacement sheets") must be submitted.
    - (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached
      - 1) ☐ hereto or 2) ☐ to Paper No./Mail Date \_\_\_\_\_.
    - (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date \_\_\_\_\_.
- Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).
7. ☐ DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

**Attachment(s)**

1. ☐ Notice of References Cited (PTO-892)
2. ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No./Mail Date \_\_\_\_\_
4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material
5. ☐ Notice of Informal Patent Application (PTO-152)
6. ☐ Interview Summary (PTO-413), Paper No./Mail Date \_\_\_\_\_
7. ☒ Examiner's Amendment/Comment
8. ☒ Examiner's Statement of Reasons for Allowance
9. ☐ Other \_\_\_\_\_

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### DETAILED ACTION

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

(Currently Amended) An apparatus for treating a workpiece with a plasma, comprising:

- a chamber having a processing space and a wall;
- a gas supply port in said chamber for introducing a process gas into said processing space;
- a workpiece holding portion positioned in said processing space and configured for holding the workpiece;
- a plasma excitation source operable for exciting process gas in said processing space to generate a plasma;
- a powered electrode electrically connected to said plasma excitation source and said workpiece-holding portion;
- a vacuum port in said chamber for evacuating said processing space,
- a vacuum distribution baffle positioned between said vacuum port and said workpiece holding portion for uniformly dispersing process gas across said powered electrode, said vacuum distribution baffle operating for electrically shielding said powered electrode from said chamber

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vacuum port and for preventing plasma generation in a portion of said processing space between said vacuum distribution baffle and said vacuum port; and

an electrical feedthrough extending through said wall of said chamber and electrically coupled with said powered electrode, said electrical feedthrough extending through said vacuum distribution baffle.

Authorization for this examiner's amendment was given in a telephone interview with Mr. William R Allen on 7/22/2005.

***Allowable Subject Matter***

2. Claims 1-7, 9-10, 12, 49-50 and 52-56 are allowed.

3. The following is an examiner's statement of reasons for allowance:

Independent claim 1 is allowable for the vacuum distribution baffle positioned between vacuum port and workpiece holding portion for uniformly dispersing process gas across a powered electrode while vacuum distribution baffle is for electrically shielding said powered electrode from said vacuum port and for preventing plasma generation in a portion of said processing space between said vacuum distribution baffle and said vacuum port; and an electrical feedthrough extending through wall of the chamber and electrically coupled with said powered electrode, said electrical feedthrough extending through said vacuum distribution baffle.

This limitation is not disclosed or suggested in the prior art in the context of other limitations of this claim.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).



Ram Kackar

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